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Examiner : G. Goudreau
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Applicant : Imad Mahawili, PhD
Serial No. : 09/488,309
Filed : January 20, 2000
For : REACTOR WITH REMOTE PLASMA SYSTEM AND
METHOD OF PROCESSING A SEMICONDUCTOR SUBSTRATE

Commissioner for Patents
P.O. Box 1450
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Dear Sir:


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on December 17, 2003.


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